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CONFIRMATION NO. 5207

<b>SERIAL NUMBER</b> 10/501,155	<b>FILING or 371(c) DATE</b> 07/13/2004 <b>RULE</b>	<b>CLASS</b> 105	<b>GROUP ART UNIT</b> 1792	<b>ATTORNEY DOCKET NO.</b> SON-2563		
<b>APPLICANTS</b> Koichiro Saga, Kanagawa, JAPAN; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/00938 01/30/2003 JLW <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-021097 01/30/2002 JLW <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b>						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <i>[Signature]</i> Examiner's Signature		<input type="checkbox"/> Met after Allowance JLW Initials	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 7	<b>TOTAL CLAIMS</b> 41	<b>INDEPENDENT CLAIMS</b> 13
<b>ADDRESS</b> RADER FISHMAN & GRAUER PLLC LION BUILDING 1233 20TH STREET N.W., SUITE 501 WASHINGTON, DC 20036 UNITED STATES						
<b>TITLE</b> Surface treatment method, semiconductor device, method of fabricating semiconductor device, and treatment apparatus						
<b>FILING FEE RECEIVED</b> 2158	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees			
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